

**PATENT NUMBER and  
ISSUE DATE**

**U.S. UTILITY Patent Application**

APPL NUM 10010950	FILING DATE 11/13/2001	CLASS 438	SUBCLASS 657	GAU 2842	EXAMINER D. LE
----------------------	---------------------------	--------------	-----------------	-------------	-------------------

**\*\*APPLICANTS:** Xia Li-Qun, Xu Ping, Yang Louis, 66.2 3-122X

**\*\*CONTINUING DATA VERIFIED:**

THIS APPLN CLAIMS BENEFIT OF 60/328,018 10/09/2001

**BEST AVAILABLE COPY**

**\*\* FOREIGN APPLICATIONS VERIFIED:**

P3 PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		6392/DD/LOW K/JW
Verified and Acknowledged Examiners's initials		
TITLE : Method of depositing low k barrier layers		

U.S. DEPT. OF COM. PAT & TRADE OFFICE, 12-34

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drawn	Fig. Drawn
		Print Fig.	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Application Examiner	
		<b>PREPARED FOR ISSUE</b>	
<p><b>WARNING:</b> The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent &amp; Trademark Office is restricted to authorized employees and contractors only.</p>			

FILED WITH: ☐ DISK (CRF) ☐ CD-ROM  
(Attached in pocket on right inside flap)